

S/N 09/945,553



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Fernando Gonzalez et al.	Examiner:	George R Fourson
Serial No.:	09/945,553	Group Art Unit:	2823
Filed:	August 30, 2001	Docket:	303.775US1
Title:	METHOD TO CHEMICALLY REMOVE METAL IMPURITIES FROM POLYCIDE GATE SIDEWALLS		

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(c)(2), Applicants hereby authorize the Commissioner to charge the fee of \$180.00 as set forth in 37 C.F.R. §1.17(p), to Deposit Account No. 19-0743. Please charge any additional fees or credit any overpayment to Deposit Account No. 19-0743.

09/28/2006 HNGUYEN1 00000090 190743 09945553
01 FC:1806 180.00 DA

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Serial No :09/945,553

Filing Date: August 30, 2001

Title: METHOD TO CHEMICALLY REMOVE METAL IMPURITIES FROM POLYCIDAL GATE SIDEWALLS

Page 2

Dkt: 303.775US1

The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

Pursuant to 37 C.F.R. 1.98(a)(2), Applicant believes that copies of cited U.S. Patents and Published Applications, and Non-Published Applications identifiable by USPTO Serial Number, are no longer required to be provided to the Office. Notification of this change to this effect was provided in the United States Patent and Trademark Office OG Notices dated October 12, 2004 and October 19, 2004. Thus, Applicant has not included copies of any US Patents or US Patent Applications identifiable by serial number that may be cited with this submission. Should the Office require copies to be provided, Applicant respectfully requests that notice of such requirement be directed to Applicant's below-signed representative. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

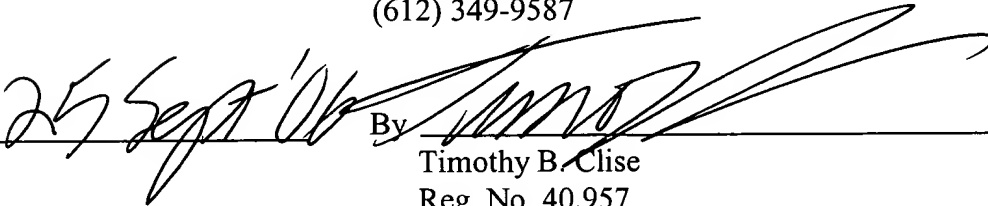
Respectfully submitted,

FERNANDO GONZALEZ ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938
Minneapolis, MN 55402
(612) 349-9587

Date

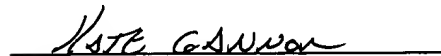


By

Timothy B. Clise
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 25 day of September 2006.

Name



Signature

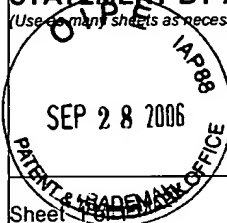


Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)



Complete if Known

Application Number	09/945,553
Filing Date	August 30, 2001
First Named Inventor	Gonzalez, Fernando
Group Art Unit	2823
Examiner Name	Fourson, George

Sheet 1 of 1

Attorney Docket No: 303.775US1

US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
	US-20050104114A1	05/19/2005	Chen, C., et al.	11/17/2003
	US-5,039,349	08/13/1991	Schoeppel, J. F.	05/18/1990
	US-5,830,802	11/03/1998	Tseng, H-H, et al.	08/31/1995
	US-6,048,803	04/11/2000	Gardner, M. I., et al.	08/19/1997
	US-6,140,163	10/31/2000	Gardner, M. I., et al.	07/11/1997
	US-6,153,509	11/28/2000	Watanabe, K., et al.	06/30/1999
	US-6,313,003	11/06/2001	Chen, H-S	08/17/2000
	US-6,429,105	08/06/2002	Kunikiyo, T.	07/10/2000

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	T ²
--------------------	---------------------	------------------	---	----------------

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		WOLF, S., Silicon Processing for the VLSI Era, (1), Process Technology, (1986), 514-517 and 551-552	

EXAMINER**DATE CONSIDERED**

Substitute Disclosure Statement Form (PTO-1446)

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional) ² Applicant is to place a check mark here if English language Translation is attached